

<b>Notice of References Cited</b>	Application/Control No. 10/500,763	Applicant(s)/Patent Under Reexamination VAN DER VEEN, MICHIEL	
	Examiner Andrew L. Nalven	Art Unit 2134	Page 1 of 1

**U.S. PATENT DOCUMENTS**

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*	A	US-2001/0051996	12-2001	Cooper et al.	709/217
*	B	US-2001/0008557	07-2001	Stefik et al.	380/202
*	C	US-7,058,809	06-2006	White et al.	713/176
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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